

# **Notice of References Cited**

Application/Control No.

09/782,586

Applicant(s)/Patent Under  
Reexamination  
ARONOFF ET AL.

Examiner

Chongshan Chen

Art Unit

2172

Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,289,357	09-2001	Parker, Christopher F.	707/202
	B	US-6,151,607	11-2000	Lomet, David B.	707/202
	C	US-6,122,640	09-2000	Pereira, Hilton M.	707/103R
	D	US-6,253,212	06-2001	Loaiza et al.	707/202
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

## **FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.